PATENT CLAIMS

1. \ A high-power semiconductor module (10), in which a number of flat semiconductor chips (14) rest with their lower face flat on a base plate (11), establishing first electrical contacts, and have a cover plate (13), which is arranged parallel to the base plate (11), applied to their upper face with pressure, establishing second electrical contacts. characterized in that those faces, or outer faces, of the base plate (11) and of the plate (13)which face away semiconductor chips (14)are each electrically isolated from the semiconductor chips (14).

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The high-power semiconductor module as claimed in characterized in that electrically conductive, elastic connecting element, preferably in the form of a first contact spring (15), is arranged between the upper face of each semiconductor chip (14) and the cover plate (13).

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- The high-power semiconductor module as claimed in 3. 25 one of claims 1 or 2, characterized in that the (11)comprises' base plate an electrically insulating substrate (17) which has a first metal coating (19) on the inner face, and in that the semiconductor chips (14) are mounted, preferably 30 by techniques such as bonding, soldering or welding, preferably by soldering, on the first metal coating (19).
- The high-power semiconductor module as claimed in 4. 35 claim 3, characterized in that the substrate composed of a ceramic, preferably an ceramic.

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5. The high-power semiconductor module as claimed in one of claims 3 or 4, characterized in that the base plate (11) is provided with a second metal coating (18) on the outer face.

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6. The high-power semiconductor module as claimed in one of claims 3 to 5, characterized in that, in an area located outside the semiconductor chips (14), pressure applied to the first coating (19) \by the cover plate (13),thus establishing a third electrical contact.

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The high-power semiconductor module as claimed in claim 6, characterized in that the third electrical contact is established via a second electrically conductive, elastic connecting element, preferably in the form of a second contact spring (16).

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The high-power semiconductor module as claimed in 8. one of claims 6 or 7, characterized in that the cover plate (13) comprises a first isolation plate (20), on whose inner face a first metallic contact plate (21) is arranged, via which the second electrical contacts with the semiconductor chips established, t\hat are and in metallic contact plate (23) is arranged on the metallic contact plate (21), electrically isolated from it, via which the third electrical contact with the first metal\ coating (19) on the base plate (11) is established.

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9. The high-power semiconductor module as claimed in claim 8, characterized in that the first and the second metallic contact plates (21 and 23, respectively) are isolated from one another by a second isolation plate (22).

- 10. The high-power semiconductor module as claimed in one of claims 1 to 9, characterized in that an electrically insulating housing (12) is arranged between the base plate (11) and the cover plate (13), and encloses the semiconductor chips (14)and the associated contact devices (15, 16).
- 11. The high-power semiconductor module as claimed in one of claims 1 to 10, characterized in that the semiconductor chips (14)are connected electrically in \parallel within the high-power semiconductor module (10).
- The high-power semiconductor module as claimed in 12. claim 11, characterized in that at least some of the semiconductor chips (14)are controllable semiconductor switches, in particular IGBTs.
- semiconductor module 13. Use οf a high-power claimed in one of claims 1 to 12 in a powerelectronics system, in which t****þe high-power semiconductor module (10)is arranged together with a cooling apparatus (24), which as adjacent to the outer face of the base plate (11) to form a stack, and pressure is applied to it \in the 25 stack.

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